

CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)

Applicant(s): WENBING YUN ET AL.

Docket No.

LBL-IB-1498-1

Serial No.

Filing Date

Examiner

Group Art Unit

Invention: **METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES**

I hereby certify that the following correspondence:

INFORMATION DISCLOSURE STATEMENT (Page 1)*(Identify type of correspondence)*

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under
37 CFR 1.10 in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on

August 9, 2001*(Date)***JOHN P. O'BANION***(Typed or Printed Name of Person Mailing Correspondence)**(Signature of Person Mailing Correspondence)***EL484718562US***("Express Mail" Mailing Label Number)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)

Applicant(s): WENBING YUN ET AL.

Docket No.

LBL-IB-1498-1

Serial No.

Filing Date

Examiner

Group Art Unit

Invention: **METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES**

I hereby certify that the following correspondence:

CITATIONS (3)

(Identify type of correspondence)

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under
37 CFR 1.10 in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on

August 9, 2001

(Date)

JOHN P. O'BANION

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

EL484718562US

("Express Mail" Mailing Label Number)

Note: Each paper must have its own certificate of mailing.